Versatility of Laser Enhanced Direct Print Additive Manufacturing

Omer F. Firato1, Roger Tipton2, Venkat Bhethanabotla2, Jing Wang3, and Thomas Weller1
1 School of Electrical Engineering and Computer Science, Oregon State University, Corvallis, OR, USA
2 Department of Chemical Biological and Materials Engineering, University of South Florida, Tampa, FL, USA
3 Department of Electrical Engineering, University of South Florida, Tampa, FL, USA
*firato@oregonstate.edu

Abstract

This paper provides examples of the use of direct print additive manufacturing to fabricate RF/microwave and optical components. Direct print additive manufacturing is the combination of extrusion and micro-dispensing on a single tool. The design, 3D printing process and material selections for finite ground coplanar waveguide (FG-CPW) planar transmission lines, the integration of DC contact RF MEMS switches within the FG-CPWs, and optical interconnects are detailed. Picosecond-pulsed laser machining is performed to enhance the finish quality of the devices and achieve minimum feature size down to 6 μm specifically for the RF switch.

Introduction

Interest in using additive manufacturing (AM) techniques has been steadily growing in recent years. Important advances have expanded AM processing capabilities, including the commercially available variety of printable materials and achievable minimum feature size. In addition, the wide-spectrum application of AM in diverse applications such as aerospace, biomedical as well as RF and microwave technologies has increased. For example, next generation jet engine fuel nozzles will be 3D printed, yielding an improvement of approximately 10% fuel efficiency [1]. Printed electronics, a focus of this paper, has a market value of $7.8 billion in 2020 with projected growth at a compound annual growth rate (CAGR) of 21.5% from 2020 to 2025. By considering the emergence and demand of 5G and microwave circuits, traditional fabrication processes require multiple steps, including photolithography and etching, while AM methods include print and cure processes in a cost-effective manner without requiring toxic materials such as photoresist developer and chemical etchants. In this sense, AM offers a possible alternative technology that can displace conventional fabrication techniques such as molding, milling, PCB, and photolithography.

LE-DPAM has the potential to enable low parasitic and tight integration of high-performance packaging systems with

DPAM can enable the printing of a complete multi material device.

One of the most important advantages of AM is to realize relatively complex geometrical structures with minimal infrastructure that generates low material waste. In the case of RF and microwave circuits, traditional fabrication processes require multiple steps, including photolithography and etching, while AM methods include print and cure processes in a cost-effective manner without requiring toxic materials such as photoresist developer and chemical etchants. In this sense, AM offers a possible alternative technology that can displace conventional fabrication techniques such as molding, milling, PCB, and photolithography.

Fig. 1. RF MEMS switch designs in suspended FG-CPW, (a) design #1, and (b) design #2. Purple, brown and green represent ABS substrate, ABS suspended bridge and CB028, respectively.

Fig. 2 (a) Case #1; Direct print additive manufacturing (DPAM) process for (a) FDM to deposit ABS substrate with the embedded cavity; (b) CB028 micro-dispensing on top of printed ABS bridge suspended across the cavity.
integrated circuits. Several 3D printed optical and RF components and circuits such as transmission lines, on-chip passives, multilayer packages, interconnects, antennas, waveguides, and filters have been successfully demonstrated with lowcost and comparable performance with other traditional fabrication techniques.

In this paper, the feasibility of AM with the realization of LE-DPAM electrical, electromechanical, and optical applications is presented. The fabrication processes are detailed by showing the capability of controlling surface roughness, aspect ratio, layer thickness, that influences RF and optical performance of the fabricated devices.

**Electrical and Electromechanical Applications**

One example of an electrical application of LE-DPAM is a new type of versatile 3D printed suspended finite ground coplanar waveguide (FG-CPW) interconnect for mm-wave packaging systems. This new approach of suspended interconnects can be utilized into an integrated system with the System-on-Package (SoP) method at microwave andmm-wave frequencies. Direct integration of multiple passive and active components with fairly low coupling can be utilized with the new suspended CPWs. They are patterned on a fixed-fixed beam and can be extended over an air cavity to other components as detailed in [3].

A new type of 3D printed electrostatically actuated radio frequency microelectromechanical systems (RF MEMS) switch that is integrated within the suspended FG-CPW is demonstrated for the electromechanical aspect of LE-DPAM (Fig 1). RF MEMS switches are important components for RF circuits and are utilized in wireless communications and defense applications, etc. There are two important parameters for electrostatic RF switches, the RF performance and the actuation or pull-in voltage. The switch is in the form of a cantilever fixed-free beam and is laser machined within the signal trace of the suspended CPWs as detailed in [4].

AM has advantages over traditional RF switch techniques such as compatibility with package integration, material variety with lower elasticity, which directly affects pull-in voltage, and low cost. For example, widely used MEMS structural materials, Si, Ni, and Ag have a Young’s modulus of 160 GPa, 77.5 GPa, and 207 GPa, respectively, while ABS and Dupont CB028, two widely used 3D printable materials, have much lower Young’s modulus of 1.57 GPa and 7.71 GPa, respectively.

**Design and Fabrication Flow of Suspended CPW and Cantilever Beam**

ABS is a thermoplastic material with a measured dielectric constant (εr) of 2.35 and a loss tangent (tanδ) of 0.0065 at 30 GHz and is printed with an FDM process. ABS is extruded with 125 μm inner / 175 μm outer diameter ceramic nozzle at 235°C onto a 110°C heated metal printer platform to form the substrate (nScrypt 3Dn tabletop).

Since the device is essentially suspended and needs a suspended layer, a form of cavity is required underneath the top ABS layer (suspended ABS bridge) and there are two ways to achieve this. First (case #1), a suspended ABS bridge could be printed as a top layer as seen in Fig. 2 (a). Extrusion of ABS filaments through a ceramic tip ends up as a cylindrical shape and the thick ABS bridges over the air cavity. A single suspended

---

**Table 1. FG-CPW and switch dimensions**

<table>
<thead>
<tr>
<th>Design No</th>
<th>Length (μm)</th>
<th>Signal width (μm)</th>
<th>Slot (μm)</th>
<th>Length (μm)</th>
<th>Width (μm)</th>
<th>Gap (μm)</th>
</tr>
</thead>
<tbody>
<tr>
<td>#1</td>
<td>1500</td>
<td>180</td>
<td>20</td>
<td>750</td>
<td>20</td>
<td>6</td>
</tr>
<tr>
<td>#2</td>
<td>2400</td>
<td>180</td>
<td>20</td>
<td>1800</td>
<td>40</td>
<td>7</td>
</tr>
</tbody>
</table>

---

**Fig. 4. Using a composite additive and subtractive LE-DPAM process for producing CCS optical fiber interconnects on a PCB board. (b) The LE-DPAM printing process for fabricating an optical interconnect where an FDM additive manufacturing tool is used to print an ABS base on a PCB board to get the fibers to the correct end facet heights to align components and a cladding material is micro-dispensed onto the substrate. (c) The cladding material is cured with UV energy. (d) The fiber is embedded within the cladding material. (e) The end facets are prepared using a subtractive laser process, and finally components are mounted to the board where communication is via the CCS optical fiber for the electromechanical aspect of LE-DPAM (Fig 1). RF MEMS switches are important components for RF circuits and are utilized in wireless communications and defense applications, etc. There are two important parameters for electrostatic RF switches, the RF performance and the actuation or pull-in voltage. The switch is in the form of a cantilever fixed-free beam and is laser machined within the signal trace of the suspended CPWs as detailed in [4].**

---

**Fig. 3. SEM images of (a-b) laser machined AM CPW crossovers; (c) 20 μm slot in silver paste; (d) the sidewall of the cantilever beam; (e) RF switch cantilever beam design #1 incorporated within the CPW signal line.**
ABS bridge diameter is the outer diameter of the ceramic nozzle (for this case, 175 μm). Second (case #2), the suspended top ABS layer could be printed as a first layer in the substrate and by flipping it over, the suspended layer could be the top layer as seen in Fig. 2 (b). The thickness and shape of this layer, that becomes the suspended ABS bridge by flipping the structure, can be controlled easily because it prints directly over the printer bed.

Since surface roughness is an important parameter for especially high frequency RF applications due to the skin depth effect, the surface finish of the suspended ABS bridges needs to be smooth so that the conductive layer surface roughness would be smooth as well. Therefore, the case #2 fabrication procedure allows us to build devices with better RF performance.

After the design is completed, a 0.4 mm thick ABS substrate with 0.15 mm deep air cavity is formed along with printing 4 mm long suspended ABS bridges. For case #1, the thickness of the ABS bridges is approximately 175 μm while for case #2, it is around 50 μm. Laser heating can be applied to partially flatten the surface and reduce the thickness of the ABS bridges for case #1; thinning down to 125 μm is detailed in [3].

After the FDM print is performed, Dupont CB028 as a conductive paste is microdispensed using 125 μm inner/175 μm outer diameter ceramic tip onto the suspended bridges to realize conductive traces with an average thickness of 30 μm. The printed samples are then cured in-situ at 90 °C for 1 hour to achieve 2e6 S/m conductivity.

Finally, laser machining is performed with a picosecond pulse laser to form 50-ohm CPW lines by machining 20 μm wide slots as seen in Fig 3 a-d. Average power (Pav) of 0.4 W at a repetition rate of 100 KHz with a wavelength of 355 nm was used for the laser machining process. Laser machining enhances 3D printing finish quality due to the cold ablation effects and enables controlling the minimum dimensions of the critical features such as transducer gap of the RF switch cantilever beam down to a few microns with a high aspect ratio as seen in Fig. 3 (d). Also, CB028 conductivity achieves 10e7 S/m with the effect of cold ablation so the RF performance of CPW lines improves. Two designs of cantilever beams (Fig. 1) within the RF signal path of the suspended CPWs are laser machined to realize a RF MEMS switch (Fig 3-e) as detailed by Firat et al. [4], and their design dimensions are listed in Table 1.

**Optical Application**

New additive and subtractive manufacturing techniques have enabled the development of a new generation of optical fiber interconnect devices on rigid, including PCB boards, and flexible substrates. The basic process has been outlined by Tipton et al. [8]. A 125 μm Kapton material is used as the substrate. A commercially UV-curable optical adhesive blend of aliphatic urethane acrylate and acrylate monomer (Norland 1369 optical adhesive) cladding material was added using an LDM process and partially cured using UV energy (BLAK-Ray Long Wave Ultraviolet Lamp, Model B 100 AP/R) under a nitrogen environment. A commercially available PMMA filament material (Treed, part number HIRMA) was used to extrude a 75 μm fiber is embedded into the middle of the cladding material using an additive DFM process. The new fiber/cladding assembly is fully cured. Finally, the end facets are prepared with the subtractive 355 nm picosecond laser [9]. The process and equipment are illustrated in Figure 4. Finished fiber optic interconnect assemblies have been produced up to 250 μm thick, 3 mm wide and 10 cm long.

**Fiber Diameter and Temperature vs Surface Roughness**

A low surface roughness is critical to the performance of an optical fiber interconnect. Commercial optical fibers have an RMS surface roughness of about 300 nm for a 62.5 μm fiber. A surface roughness of less than 100 nanometers has been achieved using the LE-DPAM process for a 75 μm optical fiber.

In the evaluation of the fiber surface roughness, low pressure SEM (Quanta 3D Dual Beam Imaging System) was used due to the nonconductive nature of the PMMA material and the
small feature size of the surface variation (see Fig 5a). The RMS surface roughness was then characterized using image processing software from ImageJ, which was used to determine the edge of the fiber and then measured to determine the variation and the edge profile as shown in Fig 5b.

Surface roughness is dependent on processing conditions and nozzle diameter. The main processing variables in our FDM process are liquefier temperature, extruder filament speed, and extruder traverse speed. Through a design of experiments an optimum condition of 266°C, 0.03 mm/s, and 10 mm/s respectively have produced an RMS surface roughness of about 80 nm for the 75 μm fiber as shown in Figure 5c, e, and d.

Fiber diameter also plays an important role in surface roughness. Below a diameter of about 40 μm extrusion forces increase in the liquefier. Below 40 μm, the surface roughness increases rapidly to over 600 nm for 14-μm fibers. This behavior can be quantitatively explained by the reduction in nozzle diameter increasing the force required to extrude the fiber. The force inside the liquefier is a function of the geometry, material properties, and the temperature inside the liquefier which effect the shear rate and pressure drop. Because of these changes in shear rate and pressure drop, the fiber surface roughness is affected, which in turn affects the transmission capabilities of the fiber.

The temperature distribution is the only unknown and must be measured internally or calculated using numerical simulation. For this study, the external temperatures were measured in six locations and ANSYS. Steady State Thermal was used to determine the internal temperature of the liquefier and the polymer melt. Our liquefier consists of a hot zone that is generated by a single rod type cartridge heater, a heat break zone, and a polymer melt. The main processing variables in our liquefier consists of a hot zone that is generated by a single rod type cartridge heater, a heat break zone, and a polymer melt. The main processing variables in our liquefier consists of a hot zone that is generated by a single rod type cartridge heater, a heat break zone, and a polymer melt.

A reduction in filament diameter from 1.75 to 1.0 mm is one possible way of improving the surface roughness in smaller diameter fibers.

**Conclusion**

The versatility of laser enhanced direct print additive manufacturing is demonstrated with its applications in three main categories, namely electrical, electromechanical, and optical. LE-DPAM enables interconnects for mm-wave integrated packaging, RF MEMS switches and optical interconnects. The fabrication steps with optimization processes are detailed along with the demonstration of a variety of printable materials.

**References**


**Author Biography**

Omer Firat received his BS in electrical engineering from İnönü University, Turkey (2013) and his master’s in electrical and computer engineering from University of Delaware (2017) and, currently pursues his Ph. D in electrical engineering at Oregon State University. His research interests; RF switches and reconfigurable additively manufactured RF circuits.

Roger B. Tipton is a PhD Candidate in the Department of Chemical, Biological, and Materials Engineering at University of South Florida. His research interests include additive manufacturing, flexible optical and electronic sensors, and sensor applications for industry to improve user performance, health, and safety.

Thomas Weller received the B.S., M.S. and Ph.D. degrees in Electrical Engineering in 1988, 1991, and 1995, respectively, from...
University of Michigan. He is currently School Head in Electrical Engineering and Computer Science. His research interests are tunable and reconfigurable microwave circuits, microwave applications of additive manufacturing and 3D printing.